

## INFORMATION DISCLOSURE STATEMENT

Substitute FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE (Rev. 8-830) PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASE0101	SERIAL NO.
LIST OF ART CITED BY APPLICANT	APPLICANTS TODD EVAN SCHLESINGER	
(Use several sheets if necessary)	FILING DATE November 26, 2001	

JCS58 U.S. PTO

10/002789

11/26/01

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number								Date	Name	Class	Subclass	Filing Date if Appropriate
MS	4	9	4	5	8	5	6						
	3	7	6	7	5	5	9						
	4	5	3	9	2	2	8						
	5	5	7	8	7	7	5						
	5	8	8	3	3	1	9						
MS	5	8	8	8	5	9	1						

## FOREIGN PATENT DOCUMENTS

	Document Number								Date	Country	Class	Subclass	Translation Yes No	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Page, Etc.)

MS	"Plasma Deposition and Treatment of Polymers", ed. W.W. Lee, R.d'Agostino, and M.R. Wertheimer, ISBN 1-55899-450-5, published by Materials Research Society.
MS	"Reactive Sputtering of PTFE Films in Argon-CF4 Mixture", Lehmann et al, Thin Solid Films, 1978, 231-235
MS	"Deposition of Polymer Films in Low Pressure Reactive Plasmas", Bederman, Thin Solid Films, 1981, 125-135
Examiner	Date Considered 10/20/01

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.